

@exatron MODEL 650 LIM

LINEAR INSPECTION AND MARKING SYSTEM



- Linear motor-driven XY table with digital encoders ensures precise movement and marking.
- Inspection measures X, Y, angle of entire wafer or of individual devices and sends to laser, which ensures precise marking.
- Add-a-mark method allows alignment of new mark file with existing device markings.
- Marks an entire wafer/tray or individual devices.
- Easily configurable for waffle packs, JEDEC, and custom trays.
- Designed, manufactured, and assembled in San Jose, CA USA.

- Features **KEYENCE** inspection camera and laser marker
 - Camera is equipped with a telecentric lens
 - Laser has a 125 x 125 mm or 330 x 330 mm marking area.
- Touchscreen Windows 11 interface.

